

# Advancement and Innovation for Detectors at Accelerators

# WP11 Reporting period 2

CERN 20 jun 2024

**WP 11** 

**Microelectronics** 

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### WP11 Objectives

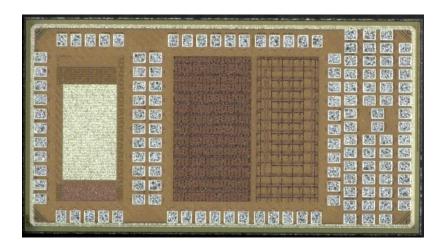


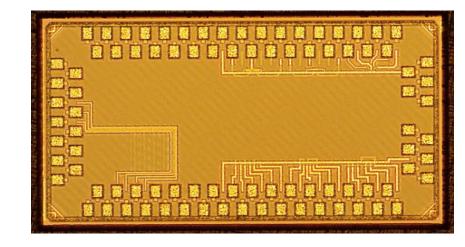
- Task 11.1. Coordination and Communication [CNRS+INFN]
- Task 11.2. Exploratory study of advanced CMOS (28 nm)
  - INFN PV, AGH, CNRS CPPM, UBONN
  - Explore advanced 28 nm CMOS for future trackers AGH, CNRS CPPM
  - Design and test front-end prototypes INFN PV, UBONN
  - Milestone MS45 and deliverable D11.1
- Task 11.3. Networking and ASICs for other WPs (65/130 nm)
  - AGH, CNRS OMEGA, IP2I, DESY, INFN (BA, BO, PV, TO) Uni Heidelberg, WEEROC (industry)
  - Cold and timing ASICs in 65/130nm CMOS: CNRS OMEGA, IP2I
  - MPGD readout ASICs : INFN (BO, TO)
  - Silicon and SiPM readout ASICs for future colliders and timing applications: AGH, CNRS OMEGA, DESY, UniH, WEEROC
  - Milestone MS46 and delivierable D11.2



### WP11.2 deliverable

- D11.1: MPW in 28 nm
  - 2 chips submitted by CNRS/CPPM and INFN PV/BG fabricated mid 2023
  - Deliverable exists but report delayed







### 28 nm @CPPM





### 28 nm chip design



#### R&D on hybrid pixels

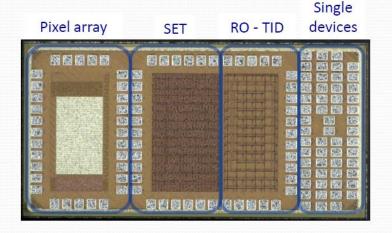
- Process qualification in terms of performance for analog, low-power and low-noise circuits
- Architecture studies
- Fast charge amplifier array

#### Study of Single Event Effects (SEE)

- Measure the SET cross-section
- Measure the SET pulse width with a good resolution < 20 ps</li>
- Measure the effect of the std cell size

#### TID tests and qualification

- Compatibility with typical dose levels for future projects
- 28 nm process device qualification
- Gate delay evolution with TID and the effect of the std cell size
- TID Effects modeling → Analog and digital simulations with TID effects



Mini@sics of 2×1 mm2 received June 2024, consisting of 4 main blocks

- Analog pixel array (25×25 μm2) with Fast charge amplifiers for high time resolution
- SET test structures
- Ring Oscillators for TID tests on digital standard cells
- Test structures for TID tolerance studies

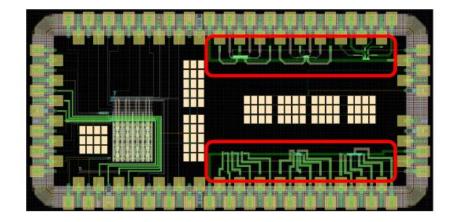


### 28 nm at INFN BG/PV

### Technology characterization

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- 18 differently sized core, standard-threshold devices, both P-channel and N-channel in triple well
  - · channel length: 30 nm, 60 nm and 180 nm
  - channel width: 100 um, 200 um and 600 um (finger width Wf = 2.5 um -> 40, 80 and 240 fingers)



- Static and signal parameters measured with an Agilent B1500A Semiconductor Parameter Analyzer
- Noise power spectral density measurements carried out with an HP4395A Network/Spectrum Analyzer and a noise amplification system
  - Drain current in DUTs: from 50  $\mu$ A to 500  $\mu$ A  $\rightarrow$  low power operation as in high density front-end circuits

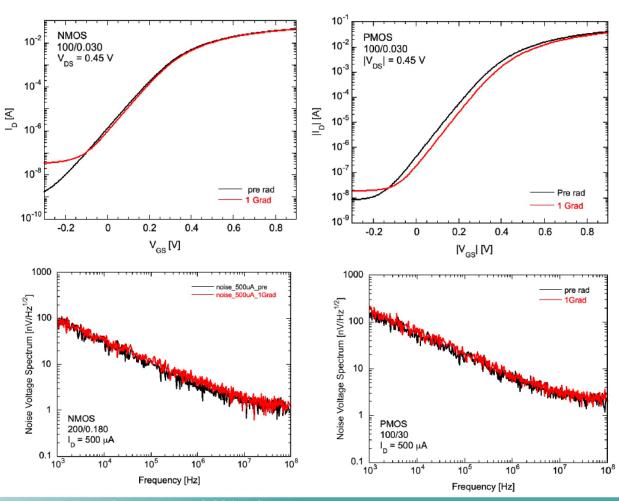


### 28 nm at INFN BG/PV

### Ionizing radiation effects

- Investigated devices irradiated up to 1 Grad(SiO<sub>2</sub>) total dose with X-rays (5.5 Mrad/h dose rate)
- MOSFETs biased during irradiation in the worst-case condition
- Slight increase in drain leakage current after irradiation
- Limited threshold voltage changes (depending on MOS polarity and geometry)
- Up to 1 Grad, NMOS and PMOS do not feature significant change in their noise properties after irradiation

Thanks to Serena Mattiazzo and Devis Pantano (INFN PD) for their valuable support during the irradiation campaign!



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### WP11.3 Deliverable

#### Layout Draft of E-ITO-TMSS02-001

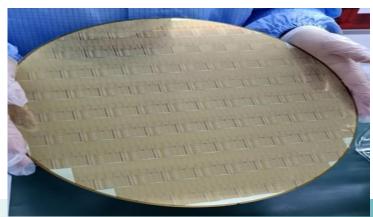
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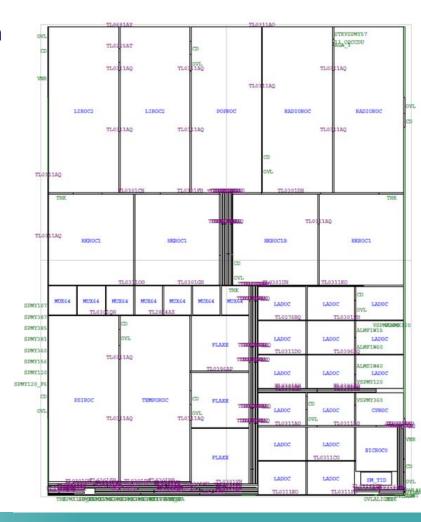
#### D11.2 : MPW in 130 nm

- AIDA participation in a 130nm engineering run
- ~25% of the reticle area (total cost 300k€)
- Fabricated in may 23 received jan 24

#### 5 chips from AIDA :

- FLAXE (AGH): Si/GaAs readout
- EICROC (OMEGA/AGH/CEA) : LGAD readout
- CPROC (OMEGA) : RISC5
- LIROC (WEEROC): SiPM timing
- PSIROC (WEEROC) : Si readout



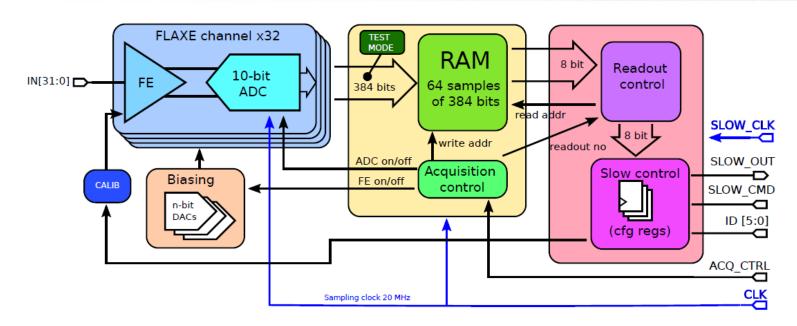




### 130 nm at AGH



# Activities in CMOS 130nm FLAXE ASIC for ECAL-p in LUXE experiment



- •FLAXE is a modified 32-channel FLAME in CMOS 130nm without high speed serialisers&transmitters readout rate in LUXE ~10 Hz
- •More than 1000 FLAXE chips were produced. Sent for dicing and packaging recently...



### 130 nm at WEEROC

### Applications for LIROC



- QUANTUM : True Random Number Generation : Random Power spa
- LIDAR : atmospheric LIDAR : ADS / CNES
- LIDAR : Onera
- LIDAR : ISRO
- LIDAR : Leica Geosystem



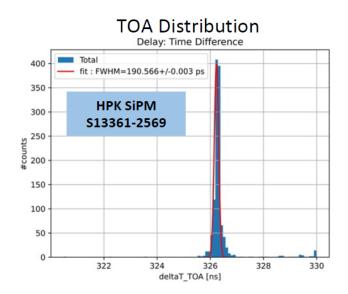


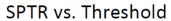
### 130 nm at WEEROC

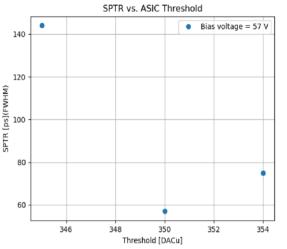
### Liroc-picoTDC system: Improved time resolution (SPTR)



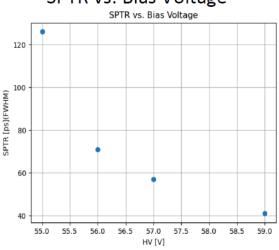
#### HPK SiPM S13361-2050NE-08







#### SPTR vs. Bias Voltage



- TOA measurement: best SPTR HPK S13361-2569 is 191 ps (FWHM) at 57 V.
- Improved SPTR for a standard HPK S13361-2050NE-08: 58 ps (picoTDC) compared to 167

REVISED: August 15, 2023 ACCEPTED: September 21, 2023

Study experimental time resolution limits of recent ASICs at Weeroc with different SiPMs and scintillators

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### Summary

- 2 main pillars in AIDA INOVA
  - Explore 28 nm technology performance for HEP
  - Provide readout ASICs in 130nm for other WPs
- 2 fabrications done in 2023 to match these objectives
  - Milestones MS45/46 and deliverables 11.2/11.3
- First results shown at the annual meeting, more to come...
  - Complex chips => long testing time
- More designs also continuing in 28, 65 and 130 nm...
- At least 3 publications (AGH), probably more to be counted

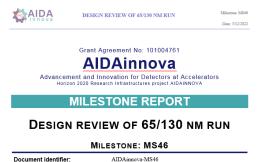


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### Deliverables/Milestones

- 2 Milestones and 2 deliverables
  - MS 11.1 and 11.2 (MS45 MS46) passed end 2022
  - D11.1 and 11.2 are the corresponding chips



MS11.1	Design review of 28 nm MPW	11.2	18	report
MS11.2	design review of 65/130 nm run	11.3	18	report

Deliverables related to WP11				
D11.1: MPW 28 nm	24			
The deliverable is a multi-project wafer fabrication with the different test ASICs in CMOS 28 nm				
D11.2: MPW 65/130 nm				
The deliverable is a multi-project wafer fabrication with ASICs in CMOS 65 and/or 130 nm that can be used to readout detectors from the other WPs and in particular WP8	24			
D11.3: Measurement reports				
Each of the ASIC fabricated in the 2 previous deliverables will have its design and performance documented in a report				